

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S18 2	330	virtual technology	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	NEAR	ON	2006/02/14 13:54
S18 3	1	virtual technology subset semiconductor	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	SAME	ON	2006/02/14 13:53
S18 4	10	virtual subset semiconductor	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	SAME	ON	2006/02/14 13:48
S18 5	0	virtual technology subset semiconductor	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	WITH	ON	2006/02/14 13:54
S18 6	2726	virtual technology subset semiconductor	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2006/02/14 13:54
S18 7	16	S182 and subset and semiconductor	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/02/14 13:56
S18 8	2	semiconductor (manufacturing or fabricat\$3) virtual repository	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	SAME	ON	2006/02/14 13:59
S18 9	264	semiconductor (manufacturing or fabricat\$3) virtual repository	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2006/02/14 13:59
S19 0	232	semiconductor (manufacturing or fabricat\$3) virtual repository file	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2006/02/14 13:59

S19 1	212	semiconductor (manufacturing or fabricat\$3) virtual repository file technology	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2006/02/14 14:00
S19 2	151	semiconductor (manufacturing or fabricat\$3) virtual repository file technology subset	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2006/02/14 14:00
S19 3	151	semiconductor (manufacturing or fabricat\$3) virtual repository file technology subset method	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	AND	ON	2006/02/14 15:33
S19 4	6940	process release standards	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	SAME	ON	2006/02/14 15:34
S19 5	92	module process release standards	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	SAME	ON	2006/02/14 15:38
S19 6	1	module process release standards	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	NEAR	ON	2006/02/14 15:34
S19 7	17	S195 and semiconductor	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	SAME	ON	2006/02/14 15:38